

FORM PTO-1449

**INFORMATION DISCLOSURE CITATION
IN AN APPLICATION**

(Use several sheets if necessary)

Docket Number (Optional)
81784.0182

Application Number
09/148,606

Applicant

Kiyoshi YONEDA

Filing Date

September 4, 1998

Group Art Unit

2674

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO

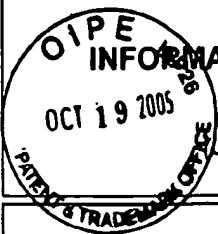
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

191	Notice to Submit Argument for the corresponding Korean Patent Appl. No. 10-1998-36721 with its excerpt English translation
1	Japanese Patent Laid-Open Publication No. Hei 9-61843 with English Abstract
191	Japanese Patent Laid-Open Publication No. Hei 8-201846 with English Abstract and excerpt English translation

EXAMINER**DATE CONSIDERED**

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EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
DL	6,136,632	10/24/00	Seiichiro HIGASHI			

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	Translation	
						YES	NO
DL	97/23806	07/03/97	WO			Abstract	

OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)

EXAMINER

DL 025

DATE CONSIDERED

12/5/05

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